

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S): Jae-Geol Cho et al.

SERIAL NO.: 10/735,192

EXAMINER: John A. McPherson

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ART UNIT: 1795

TITLE: METHOD OF FABRICATING MICRO-LENS AND METHOD OF  
FABRICATING OPTICAL MODULE USING THE METHOD

CERTIFICATE OF MAILING UNDER 37 CFR §1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the ASSISTANT COMMISSIONER FOR PATENTS, P.O. BOX 1450 ALEXANDRIA, VA 22313 on February 19, 2008.

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Sir:

INFORMATION DISCLOSURE STATEMENT

In accordance with Applicant's and Applicant's representatives' Duty of Disclosure under 37 CFR § 1.56, and pursuant to 37 CFR §1.97(d) and MPEP 717.05(b), Applicant(s) submit herewith documentary information for consideration by the Examiner. Information herein cited is only set forth in fulfillment of Applicant's duty of candor in disclosing all information brought to his attention, and is not an admission that it can be used adversely. The publications forwarded herewith are listed on the enclosed Form PTO-1449. Applicant(s) request that the Examiner, upon reviewing the enclosed materials, initial the enclosed form and return a copy thereof in accordance with the instructions on the form.

Applicant further note that each item of information contained in the enclosed Form was first cited from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the statement.

Enclosed please find copies of 3 Foreign Reference listed on the attached Form PTO-1449.

Respectfully submitted,

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